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GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

January 10, 2026

IGI Report Number **LG749540532**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **ROUND BRILLIANT**

Measurements **9.29 - 9.33 X 5.60 MM**

GRADING RESULTS

Carat Weight **2.96 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

Cut Grade **IDEAL**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

IGI **LG749540532**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type Ila

LG749540532
Report verification at igi.org

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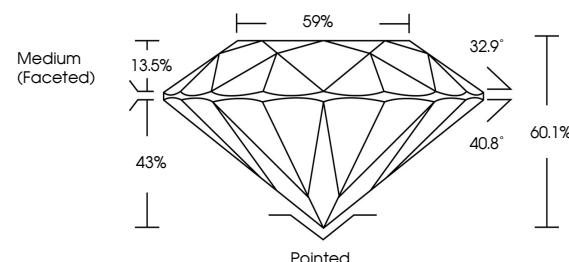
2.96 CARATS

E

VVS 2

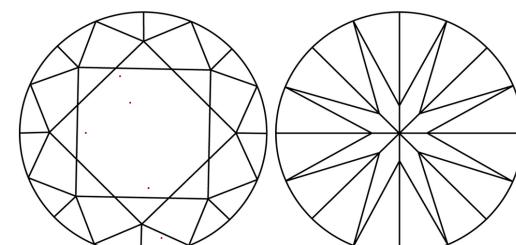
IDEAL

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
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Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
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ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

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Symmetry **NONE**

NONE

Fluorescence **None**

None

Inscription(s) **IGI LG749540532**

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